

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:

Hideomi KOINUMA *et al.*

Patent No. 7,259,409 B2

Issued: August 21, 2007

For: THIN FILM DEVICE AND ITS
FABRICATION METHOD

Examiner: Evan Pert

Confirmation No. 5810

Atty. Docket No. 32307-191598

Customer No.

26694

U.S. PATENT AND TRADEMARK OFFICE

**REQUEST FOR CERTIFICATE OF CORRECTION
PURSUANT TO 37 CFR 1.323**

Attention: Certificate of Correction Branch
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please issue a Certificate of Correction for the above-referenced patent to correct the Assignee of the above-referenced patent as follows:

On the cover page, under the subheading "(73) Assignee:" please replace "Tokyo Institute of Technology, Tokyo (JP)" with "--National Institute for Materials Science, Tsukuba-shi (JP) and Fuji Electric Holdings Co., Ltd., Kawasaki-shi (JP)--".

The correct Assignees are reflected in the Assignment that was submitted for recordation in the U.S. Patent and Trademark Office on December 21, 2010.

Transmitted herewith is a proposed Certificate of Correction effecting such amendment. Patentee respectfully solicits the granting of the requested Certificate of Correction.

Please charge Deposit Account No. 22-0261 the \$100 fee set forth in 37 CFR 1.20(a). The undersigned authorizes the Director to charge any fee deficiency associated with this communication to Deposit Account No. 22-0261, under Order No. 32307-191598.

Respectfully submitted,

Dated: December 21, 2010

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**UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION**

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PATENT NO. : 7,259,409 B2
APPLICATION NO. : 10/665,524
ISSUE DATE : August 21, 2007
INVENTOR(S) : Hideomi KOINUMA *et al.*

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

(73) Assignee: "Tokyo Institute of Technology, Tokyo (JP)" should read

--National Institute for Materials Science, Tsukuba-shi (JP)

and

Fuji Electric Holdings Co., Ltd., Kawasaki-shi (JP)--

MAILING ADDRESS OF SENDER (Please do not use customer number below):

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